

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:	)
Kei HAYASAKI et al.	) Group Art Unit: 1756
Application No.: 10/624,593	) Examiner: Barreca, Nicole M.
Filed: July 23, 2003	) Confirmation No. 7500
For: METHOD FOR FORMING A PATTERN AND SUBSTRATE- PROCESSING APPARATUS	) . ) )
Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450	
Sir:	

## SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT UNDER 37 C.F.R. § 1.97(b)

Pursuant to 37 C.F.R. §§ 1.56 and 1.97(b), Applicants bring to the attention of the Examiner the documents listed on the attached PTO/SB/08 form. Applicants submit this Information Disclosure Statement (IDS) together with a Request for Continued Examination (RCE) for the above-identified application. This IDS supplements the IDSs filed on July 23, 2003, January 10, 2005, and September 27, 2005.

With the exception of documents JP 10-300428 and JP 2000-269120, the documents listed in this Information Disclosure Statement were first cited in the Japanese Patent Office Action, mailed by the Japanese Patent Office on August 16, 2005 in a counterpart Japanese Application, a copy of which was submitted with the IDS filed on September 27, 2005.

Copies of the listed documents were also previously submitted with the IDS filed on September 27, 2005. However, at the Examiner's requirement, copies of the documents are being resubmitted at this time, together with their English translations which were obtained from the Japanese Patent Office website, with the exception of JP 60-216554, JP 63-287020, JP 1-179327, and JP 2-315. Only English-language abstracts are being submitted for these documents, because the full English translations are not available on the Japanese Patent Office website.

The relevance of the listed documents JP 10-300428 and JP 2000-269120 is discussed at page 36 of the specification. English language abstracts of the documents are also enclosed.

This submission does not represent that a search has been made or that no better art exists, and does not constitute an admission that the listed documents are material or constitute "prior art." If the Examiner applies any of the documents as prior art against any claim in the application and Applicants determine that the documents do not constitute "prior art" under United States law, Applicants reserves the right to present to the Office the relevant facts and law regarding the appropriate status of the documents.

Applicants further reserve the right to take appropriate action to establish the patentability of the disclosed invention over the listed documents, should any of the documents be applied against the claims of the present application.

If there is any fee due in connection with the filing of this Statement, please charge the fee to our Deposit Account No. 06-0916.

Respectfully submitted,

FINNEGAN, HENDERSON, FARABOW, GARRETT & DUNNER, L.L.P.

Dated: August 18, 2006

David

David M. Longo Reg. No. 53,235 IDS Form PTO/SB/08: Substitute for form 1449A/PTO

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## INFORMATION DISCLOSURE STATEMENT BY APPLICANT

(Use as many sheets as necessary)

Application Number	10/624,593
Filing Date	July 23, 2003
First Named Inventor	Kei HAYASAKI
Art Unit	1756
Examiner Name	Barreca, Nicole M.
Attorney Docket Number	04329 3100

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Complete if Known	148
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	U.S. PATENTS AND PUBLISHED U.S. PATENT APPLICATIONS					
Examiner	Cite No.1	Document Number	Issue or Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where	
Initials		Number-Kind Code <sup>2</sup> (if known)			Relevant Passages or Relevant Figures Appear	
		US-				
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Note: Copies of the U.S. Patent Documents are not Required in IDS filed after October 21, 2004

FOREIGN PATENT DOCUMENTS						
Examiner Initials	Cite No. <sup>1</sup>	Foreign Patent Document  Country Code <sup>3</sup> Number <sup>4</sup> Kind Code <sup>5</sup> ( <i>if known</i> )	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	Translation <sup>6</sup>
		JP 60-216554	10/30/1985			Abstract
		JP 63-287020	11/24/1988			Abstract
		JP 1-179327	07/17/1989			Abstract
		JP 2-315	01/05/1990			Abstract
		JP 10-300428	11/13/1998			Abstract
		JP 2000-269120	09/29/2000			Abstract
		JP 2001-85407	03/30/2001			Yes
		JP 2001-250773	09/14/2001	•		Yes
		JP 2001-332484	11/30/2001			Yes
_	<u> </u>	JP 2002-83803	03/22/2002			Yes

	NON PATENT LITERATURE DOCUMENTS			
Examiner Initials	Cite No. <sup>1</sup>	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	Translation <sup>6</sup>	

Examiner	Date	
Signature	Considered	

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.